Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	"20030161027".pn. and (lubricant or getter)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/23 10:00
L2	1	"20020063322".pn. and (electrode or wire or wiring or circuit or circuitry)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/23 10:01
L3	7	("mem" or microelectromechanical) and spatial adj light adj modulator and micromirror and (lubricant or getter) and substrate near10 silicon near10 ceramic	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/23 10:28
L4	1	"6903860".pn. and hinge	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/23 11:19
L5	0	"20050212067".pn. and "114"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/23 11:20
L6	0	"20050212067".pn. and "120"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/23 11:28
L7	14	US-5835256-\$.DID. OR US-6046840-\$. DID. OR US-6844959-\$.DID. OR US-6867897-\$.DID. OR US-5287096-\$. DID. OR US-5939785-\$.DID. OR US-5411769-\$.DID.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/23 11:31
L8	10	US-6204085-\$.DID. OR US-5447600-\$. DID. OR US-6300294-\$.DID. OR US-6086726-\$.DID. OR US-6475570-\$. DID.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/23 11:36
L9	10	US-6204085-\$.DID. OR US-5447600-\$. DID. OR US-6300294-\$.DID. OR US-6086726-\$.DID. OR US-6475570-\$. DID.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/23 11:38
L10	12	US-6533632-\$.DID. OR US-6259551-\$. DID. OR US-6664779-\$.DID. OR US-5293511-\$.DID. OR US-6624944-\$. DID. OR US-5929515-\$.DID.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/23 12:48
L11	2599	257/678.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/23 12:57

L12	253	257/682.ccls.	US-PGPUB;	OR	ON	2005/11/23 12:57
			USPAT; EPO; JPO; DERWENT			
S1	73	("mem" or microelectromechanical) and spatial adj light adj modulator and micromirror and (lubricant or getter)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/23 09:43
S2	94	("mem" or microelectromechanical) and spatial adj light adj modulator and micromirror and (lubricant or getter or lubrication)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/22 15:51
S3	2	("20020117728").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/11/22 15:44
S4	2	("6541832").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/11/22 15:44
S5	2	("20030161027").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/11/22 15:45
S6	2	("20030047533").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/11/22 15:45
S7	2	("20010048064").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/11/22 15:46
S8	2	("20010040675").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/11/22 15:47
S9	2	("20020063322").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/11/22 15:47
S10	2	("20020180016").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/11/22 15:47
S11	1	"20020180016".pn. and (lubricant or getter or lubrication)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/22 15:53

S12	1	"20020180016".pn. and glass	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/22 16:29
S13	8	("mem" or microelectromechanical) and spatial adj light adj modulator and micromirror and (lubricant or getter) and substrate near10 glass near10 ceramic	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/11/23 10:18